

10/567173

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IAP20 Rec'd PCT/PTO 03 FEB 2006

Appl. No. : Unassigned
First Inventor : AMATO, Joseph M.
Filed : Concurrently
TC/A.U. : Unassigned
Examiner : Unassigned

Confirmation No. Unassigned

Docket No. : **US03 0199 US2**
Customer No. : **24738**

Title: Offset Dependent Resistor for Measuring Misalignment of
Stitched Masks

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to calculation of the filing fee and examination please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.